



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: RONGHUA WEI ET AL.
Filed: MARCH 26, 2004
For: METHOD AND APPARATUS FOR FORMING A NITRIDE LAYER ON A BIOMEDICAL DEVICE
Serial No.: 10/811,485
Group Art Unit: 1775
Examiner: DANIEL MILLER
Atty. Dkt.: SWRI:003 (3020)

Pursuant to 37 C.F.R. 1.8, I certify that this correspondence is being deposited with the U.S. Postal Service in a first class, postage prepaid envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date below:

9/15/00 Date
Dana Fowler Name

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

STATUS INQUIRY

Pursuant to MPEP § 203.08, Applicant requests the Office to advise the undersigned of the status of this application.

Respectfully submitted,

Robert M. O'Keefe
Reg. No. 35,630

L

O'KEEFE, EGAN & PETERMAN, L.L.P.
1101 Capital of Texas Highway South
Building C, Suite 200
Austin, TX 78746
(512) 347-1611
(512) 347-1615 (FAX)